# Carrier confining mechanisms in axial $In_xGa_{1-x}N/GaN$ nanowire heterostructures

Oliver Marquardt



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### Light emission from $In_xGa_{1-x}N$





The bandgap of  $In_xGa_{1-x}N$  spans the whole visible spectrum... but crystal quality reduced due to large lattice mismatch!

### Light emission: $In_xGa_{1-x}N/GaN$ thin films





 $In_xGa_{1-x}N$  films in GaN with high In content and high structural quality are hard to achieve, due to large lattice mismatch

### $In_xGa_{1-x}N/GaN$ nanowires: elastic relaxation



Axial  $In_xGa_{1-x}N$  nanowire heterostructures facilitate elastic relaxation

Image courtesy	of M. Hanke, PDI
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### Light emission: $In_xGa_{1-x}N/GaN$ nanowires



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### Light emission: $In_xGa_{1-x}N/GaN$ nanowires



It is generally difficult to obtain blue emission from nanowires: Opposite trend compared to planar system!

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### Light emission: $In_xGa_{1-x}N/GaN$ nanowires



It is generally difficult to obtain blue emission from nanowires: Opposite trend compared to planar system! Theoretical description of nanowires required

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### Charge confining mechanisms in nanowires





#### **Planar layer**

Bulk band offsets

2 Böcklin et al., Phys. Rev. B **81**, 155306 (2010); Kaganer et al., Phys. Rev. B **85**, 125402 (2012) < □> < ⑦> < ≥> < ≥> < ≥> < >> > ≥ < ?><

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### Charge confining mechanisms in nanowires





#### **Planar layer**

- Bulk band offsets
- Polarisation

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### Charge confining mechanisms in nanowires





#### Nanowire

- Bulk band offsets
- Polarisation
- Elastic relaxation<sup>2</sup>
- Surface potentials: attractive for holes

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Atomistic model (ETBM, EPM, DFT)

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Atomistic model (ETBM, EPM, DFT)

- Accurate description of crystal lattice
- Straightforward treatment of single-atomistic features
- Alloy disorder can be taken into account

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- Computational effort depends on number of atoms
   Typical nanowire segment:
  - d = 80 nm, l = 20 nm
  - $\rightarrow$  ~ 7.5 million atoms

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Continuum approaches (EMA,  $\mathbf{k} \cdot \mathbf{p}$ )

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- Computationally cheap
- Treatment of large systems straightforward

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Continuum approaches (EMA,  $\mathbf{k} \cdot \mathbf{p}$ )

- Computationally cheap
- Treatment of large systems straightforward
- Neglects atomistic character of the crystal
- Alloys described via average (local) composition
- Treatment of single atomistic effects difficult

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### Model nanowire





- Hexagonal nanowire of diameter d
- In<sub>x</sub>Ga<sub>1-x</sub>N insertion of homogeneous In content x and thickness t
- Surface potential For homogeneous distribution of donor-related charge:  $V_{surf} \propto \varrho_d \cdot d^2$ .  $\varrho_d = 10^{17} \text{ cm}^{-3} \cong \max(V_{surf}) =$ 80 mV for a NW of d=80 nm

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• Vary x, t, and d

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  - 80 mV for a NW of d=80 nm
- Vary x, t, and d
- → Continuum approach favourable

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### **Employed formalisms**



### Strain and polarisation

Continuum elasticity theory<sup>3</sup>

#### Single-particle electronic properties eight-band k · p model for wurtzite semiconductors<sup>4</sup>

Electron-hole overlap

$$\mathcal{O} = \sum_{\mathbf{r}} \varrho_{\rm el}(\mathbf{r}) \varrho_{\rm ho}(\mathbf{r}) \tag{1}$$

#### Implementation within plane-wave framework<sup>5</sup>

- 3 Povolotskyi et al., Phys. Stat. Solidi (C) 2, 3891 (2005).
- 4 Chuang et al., Phys. Rev. B 54, 2491 (1999).
- 5 www.sphinxlib.de;

Boeck et al., Computer Phys. Commun **182**, 543 (2011); Marquardt et al., Comp. Mat. Sci. **95**, 280 (2014)

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### Interplay of polarisation and surface potential



Interplay between polarisation and surface potential – explains reduction of PL intensity with smaller In content or layer thickness

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For a NW of 80 nm diameter and 20 nm segment length:  $\rho_d = 10^{17} \text{ cm}^{-3}$  corresponds to 8.3 charges<sup>7</sup>!

7 Corfdir et al., Phys. Rev. B **90**, 205301 (2014).

8 Marquardt et al., Nano Lett. 15, 4289 (2015).

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Can atomistic effects be considered in continuum picture?

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• Typical donors: Si, O represent **shallow donors** in  $In_xGa_{1-x}N$ 

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Can atomistic effects be considered in continuum picture?

- Typical donors: Si, O represent **shallow donors** in  $In_xGa_{1-x}N$
- Model individual donors via their Coulomb potential

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<sup>7</sup> Corfdir et al., Phys. Rev. B 90, 205301 (2014).

<sup>8</sup> Marquardt et al., Nano Lett. 15, 4289 (2015).

### Electron and hole confinement



Consider individual, randomly distributed donors in a NW<sup>8</sup>

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Model system configurations

$$x = 5\%$$
  $x = 30\%$   $x = 10\%$   $x = 30\%$   
t = 1 nm t = 1 nm t = 5 nm t = 5 nm

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- Variation of emission wavelength unaffected by x and t
- Energies smaller than for homogeneous charge distribution and donor-free case

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### Ensemble average charge densities





#### homogeneous doping charge



- Average hole state confinement in good agreement with hole state in homogeneous doping charge model
- Electron localization governed by dopants strong variations

### Summary & next steps

- pfi
- Continuum model to approach elastic, piezoelectric and electronic properties of semiconductor nanowires
- Generalised to arbitrary nanostructures and materials
- Multiband k · p model can be adjusted to computational demand and accuracy
- Treatment of shallow defects possible

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- Coupling between strain and piezoelectric potentials
- Self-consistent simulations to consider excitonic effects
- Spatially dependent grid accuracy
- To which extent can deep defects be taken into account?

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### Thank you for your kind attention!